

IN THE SPECIFICATION:

TITLE OF THE INVENTION:

Please change the title of the invention to:

A DIAGNOSIS METHOD FOR SEMICONDUCTOR PROCESSING
APPARATUS

IN THE SPECIFICATION:

Page 1, between the title of the invention and line 1, insert the following
paragraph:

CROSS REFERENCE TO RELATED APPLICATION

This is a division of U.S. application Serial No. 10/229,072, filed August 28,
2002, the subject matter of which is incorporated by reference herein.